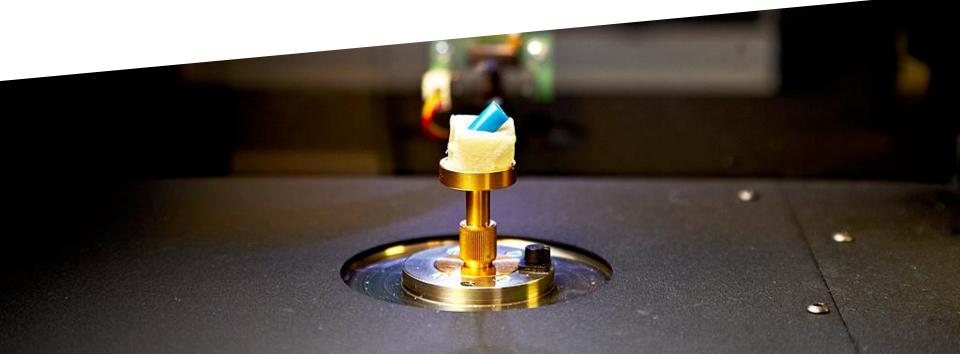


DANISH TECHNOLOGICAL INSTITUTE

### it's all about innovation





EMRP Project – Microparts Multi-sensor metrology for microparts in innovative industrial products

Maria Holmberg Metrology and Quality Assurance Danish Technological Institute



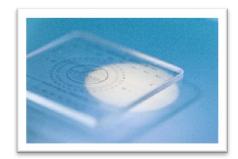
Technical field – Lenght, Geometrical Measurements

To measure on microparts, or parts with microstructures, with complex geometry in industry

Improve measurement capabilities within multi-sensor coordinate metrology

- Tactile accuracy
- Optical spead
- CT (Computed Tomography) inner structures







June 2014 – May 2016 http://www.ptb.de/emrp/microparts.html







- Work focused on accuracy and uncertainties using different probes
  - Tactile, smaller probes with increased accuracy
  - Optical, achieve traceability with reference measurements and non-linear modelling
  - CT, achieve traceability with reference measurements
- Uncertainties
- Combining data from different probes, including data fusion
- Workpiece-like reference standards
- Demonstration cases together with industry







Demonstration cases Improve measurement capabilities at LEGO and Novo Nordisk

- Performing measurements at Metrology Institutes and Designated Institutes (state-of-the-art)
- Develop protocols, methods and tools (for example fixtures, programs, guide-lines etc.)
- Dialog with industry regarding their needs
- Test in laboratories
- Test and integration at site









Demonstration cases

Industry/Production versus Laboratory Facilities

Not only 'hard technological challenges'...

- Time
- Data handling
- Competences/training
- Reproducibility
- Several production sites
- Documentation









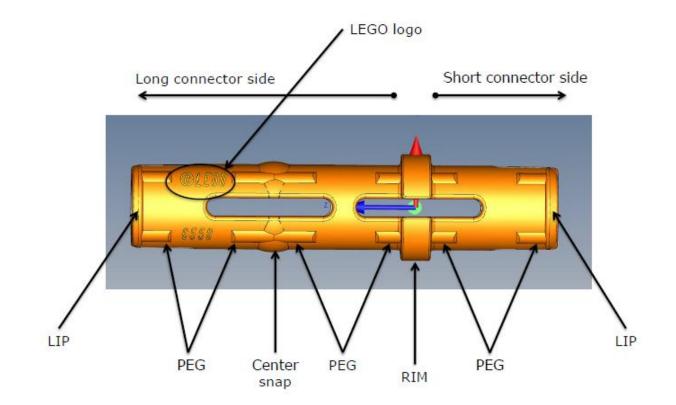
## Demonstration case – LEGO connector

Not possible to use ordinary CMM technology Get reference measurements using  $\mu CMM$  Develop protocol for optical measurements Investigate the possibility to use CT





Loff D

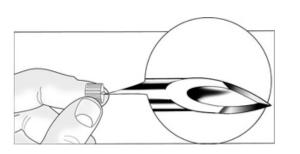


### Demonstration cases – Novo Nordisk needle

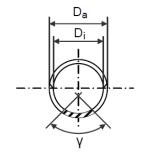
Measure internal diameters in a needle Measure angles Effect of coating

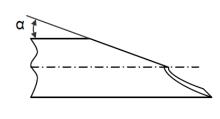


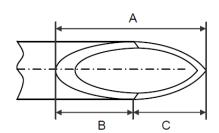
- D<sub>a</sub> Outside diameter
  - D<sub>i</sub> Inside diameter
- A Point length
- C Secondary Bevel Length
- α Primary Bevel Angle
- γ Combined Secondary Bevel Angle



-















## **CT** Scanning

#### **Zeiss METROTOM 800**

X-Ray:	130 kV
Detector:	1900 x 1512 pixels
Sample size:	12 x 15 cm (~ 4 kg
'Resolution':	< 4 µm

### Zeiss METROTOM 1500

X-Ray:	225 kV
Detector:	1024 x 1024 pixels
Sample size:	30 x 30 cm (~ 10 kg)
'Resolution':	< 10 µm

kg)

#### Bruker microCT, Skyscan 1172

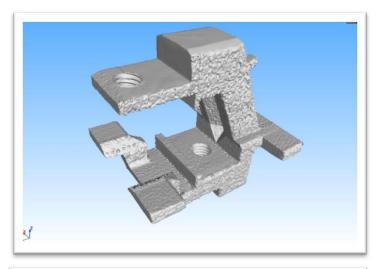
X-Ray:	100 kV
Detector:	4000 x 2300 pixels
Sample size:	2 x 2 cm
'Resolution':	< 1 µm

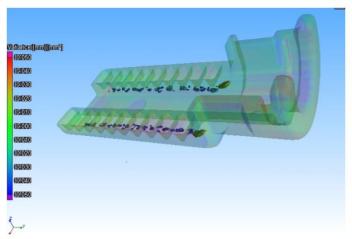


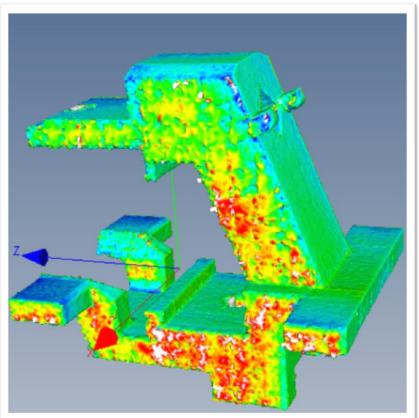




Non-destructive 3D visualization of inner and outer complex geometries









DANISH

TECHNOLOGICAL INSTITUTE

## Traceability of CT measurements

Comparison of CT measurements of a calibrated item Micro-tetrahedron calibrated with  $\mu$ CMM at PTB

Compare results from different CT Scanners Relate to reference measurements performed with synchrotron-CT and  $\mu\text{CMM}$ 

Compare to results obtained in 'industry environment' Document impact on accuracy and uncertainties





SIEMENS

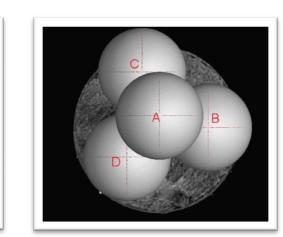


TECHNOLOGICAL INSTITUTE

DANISH







http://www.ptb.de/emrp/microparts.html

Maria Holmberg Metrology and Quality Assurance, DTI +45 7220 3006 mahg@teknologisk.dk





